

## Refine Search

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### Search Results -

Terms	Documents
(micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1	4

**Database:**

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
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 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

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### Search History

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**DATE: Friday, February 04, 2005**    [Printable Copy](#)    [Create Case](#)

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side by side		
DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR		
L10 (micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1	4	<u>L10</u>
L9 (micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	33	<u>L9</u>
L8 (micromirror\$1 or mirror\$1 or microelectromechanical) SAME substrate SAME (wir\$3 or electronic\$4 or circuit\$2) SAME substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	236	<u>L8</u>
L7 micromirror\$1 SAME substrate SAME (wir\$3 or electronic\$4 or circuit\$2) SAME substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	1	<u>L7</u>
L6 micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	0	<u>L6</u>

	NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)		
micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)			
<u>L5</u> NEAR10 substrate SAME pattern\$3 SAME (electroconductive or conductive) SAME (detect\$3 or sens\$3)		0	<u>L5</u>
micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)			
<u>L4</u> NEAR10 substrate SAME pattern\$3 SAME (electroconductive or conductive) WITH (spacer\$1 or post\$1 or column\$1)		1	<u>L4</u>
micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)			
<u>L3</u> NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1		0	<u>L3</u>
micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)			
<u>L2</u> NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) WITH angle\$1		0	<u>L2</u>
micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)			
<u>L1</u> NEAR10 substrate SAME pattern\$3		29	<u>L1</u>

END OF SEARCH HISTORY.